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# A mini scanning device for profiling charged beams 

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#### Abstract

In this article we present the development of a mini scanner device to characterize the full transverse spatial density of a charged particle beam using computed tomography. The profiler consists of a wire mounted on a linear translator that can rotate around the beam. Tests were performed on a millimeter electron beam with 200 eV energy and 100 nA intensity, which allowed us to control and monitor both beam focusing and deflection.


## I. INTRODUCTION

Beam diagnostic is of great importance nowadays for monitoring beam position, intensity and size. Position monitoring serves to correct beam position ${ }^{1}$, control of the shape serves to optimization of the intensity in a given region for focalization purpose or looking for optimization of the irradiation area which is crucial in therapy applications such as proton or hadontherapy ${ }^{2}$. Several diagnostic techniques have been proposed for this purpose.
The assembly of Micro Channel Plates coupled to a phosphor screen ${ }^{3,4} 5,6$ allows direct imaging of the beam profile and position for electron, ion and neutral beams as well as UV and X-ray photons. Care must be taken to ensure a direct match between the input signal and the corresponding image and not to saturate the MCP by lowering the input flux with several grids each corresponding to $90 \%$ attenuation. This technique is destructive because the beam is no longer available afterwards. Scintillator detectors coupled to CCD camera can be also used ${ }^{7}$. Interaction of high energy beams with residual gas will created secondary particles which will be detected by MCP and imaged by CCD device ${ }^{8}$.
Quasi non-destructive techniques using wires are also used such as harps or moving wires and the combination of two perpendicular assemblies gives profiles in the corresponding directions ${ }^{9}$.
Such a principle has been developed for $\mathrm{H}^{-}$beams using the photo-detachment process with a laser wire ${ }^{10}$, in this case, no real wire is used. This prevents the wire from heating up and possibly being destroyed by the high-intensity, high-energy ion beams.
However the problem of measuring profiles in two orthogonal directions does not allow a complete determination of the beam profile but still gives the beam position. For inhomogeneous beams, this method is no longer sufficient and more sophisticated techniques are required. Multiplying the measurements of one-dimensional profiles over several angles leads to the computed tomographic (CT) principle well known in medical applications and thus allows the full two-dimensional density to be reconstructed numerically.
CT has already been used in beam diagnostic to measure the phase space distribution: McKee et al. ${ }^{11}$ have proposed a new technique that combines CT and quadrupole scanning to reconstruct, without any assumptions, the transverse phase space distribution (and thus calculate the emittance) for a MeV electron beam.
Nanometer beam profiling using CT has been applied to an electron beam a few 10 nanometers wide, and the detection wire is a single-walled nanotube 0.4 nm in diameter ${ }^{12}$. On the other hand, for high-current, large, proton beams, which are often irregularly distributed ${ }^{13}$, CT must be used. For this, Xing et al ${ }^{13}$ has designed a rotating multi-wire scanner with 19 carbon wires spaced 3 mm apart and a sophisticated complementary translation mechanism enabling 0.1 mm linear scanning.
In this paper, we present a scanner device that is simple, easy to build, and inexpensive, using only a single wire for the profiling of a charged particle beam.

## II. TOMOGRAPHY PRINCIPLE: THE RADON AND INVERSE RADON TRANSFORM

Tomography is a widely used technique in medical imaging (see 14 and references therein). It is based on the measurement of the attenuation of X-rays by the material they are passing through.
The Berr-Lambert law, which describes this attenuation, is given by the equation:
$\mathrm{I}(\Lambda)=\mathrm{I}_{0} \mathrm{e}^{-\mathrm{g}(\Lambda)}$
Where $g(\Lambda)$ is the integral of the attenuation function $\mu(x, y, z)$ along $\Lambda$ path, corresponding to the straight line followed by the X-rays through the material between the X-ray source and the detector :
$\mathrm{g}(\Lambda)=\int_{\Lambda} \mu(\mathrm{x}, \mathrm{y}, \mathrm{z}) \mathrm{dl}$
In the following we will work at a given z and the paths $\Lambda_{\mathrm{i}}$ are in the $(\mathrm{x}, \mathrm{y})$ plane as described in figure 1


Figure 1: Principle of RX tomography a) with a point x ray source, b) parallel beams
By rotating the source relative to the object and recording the intensities on appropriate detectors (see figure 1), it is possible to obtain a complete set of $g(\Lambda)$ values whose inverse Radon transformation gives the attenuation function profile $\mu(x, y, z)$ at given z . By repeating the operation for different z , we can then produce the 3D density profiles of the traversed materials.

## A. Case of charged particles beam profiling: what do we measure?

We propose to use this technique for charged particles beam density profile.
Let $\vec{J}$ the courant density, the intensity dI of the beam current is given by $\mathrm{dI}=\overrightarrow{\mathrm{J}}$. $\overrightarrow{\mathrm{dS}} \sim \mathrm{JdS}$ for quasi parallel beam and a surface perpendicular to the beam velocity supposed to be along the $z$ direction.
$\mathrm{J}(\mathrm{x}, \mathrm{y}, \mathrm{z})$ is the density of current we want to determine at a given z (noted hereafter $\mathrm{J}_{\mathrm{z}}(\mathrm{x}, \mathrm{y})$ ) and corresponds to the beam profile. In order to obtain $\mathrm{J}_{\mathrm{z}}(\mathrm{x}, \mathrm{y})$, we will scan the beam in the ( $\mathrm{x}, \mathrm{y}$ ) plane using a thin wire (in red in figure 2) whose length is larger than the beam, perpendicular to the scanning direction (in blue). We then measure integrated current produce by the beam on it. The scanning procedure is comparable to the one showed in figure 1-b.


Figure 2: Geometry of the scanning apparatus

Here the detector is the wire itself whose position is defined by two coordinates namely the distance $\mathrm{OP}=\mathrm{p}$ (the wire is perpendicular to OP) and the angle $\theta$ between the scanning direction and the x axis. The intensity is defined as:

$$
\begin{equation*}
\mathrm{g}_{\theta}(\mathrm{p})=\int_{\text {wire }} \mathrm{J}_{\mathrm{z}}(\mathrm{x}, \mathrm{y}) \mathrm{dl} \tag{3}
\end{equation*}
$$

Note that $g_{\theta}(p)$ is completely equivalent to the $g(\Lambda)$ expression
A point $\mathrm{M}(\mathrm{x}, \mathrm{y})$ on the wire, assumed to be infinitely thin, obeys the equations:
$\overrightarrow{\mathrm{OM}}=\overrightarrow{\mathrm{OP}}+\overrightarrow{\mathrm{PM}}$
$\overrightarrow{\mathrm{OP}} \cdot \overrightarrow{\mathrm{OM}}=\overrightarrow{\mathrm{OP}} \cdot \overrightarrow{\mathrm{OP}}$
$x \cos \theta+y \sin \theta=p$
Then we can rewrite integration (3) in order to run over all the surface by introducing $\delta(x \cos \theta+y \sin \theta-p)$ where $\mathrm{x}, \mathrm{y}$ is a coordinate of a point M on the surface :
$g_{\theta}(p)=\iint J_{z}(x, y) \delta(x \cos \theta+y \sin \theta-p) d x d y$
which define the Radon Transform ${ }^{14}$.

## B. Reconstruction of the density of current distribution $\mathrm{J}_{\mathrm{z}}(\mathrm{x}, \mathrm{y})$

In a general way, let us define the two-dimensional Fourier transform:
$J_{z}(x, y)=\iint F(u, v) e^{2 i \pi(u x+v y)} d u d v$
Taking the Fourier Transform of $g_{\theta}$ on the variable $p$, we have :
$G_{\theta}(\omega)=\iint d x d y J_{z}(x, y) \int d p e^{-2 i \pi \omega p} \delta(x \cos \theta+y \sin \theta-p)$
And so:
$\mathrm{G}_{\theta}(\omega)=\mathrm{F}(\omega \cos \theta, \omega \sin \theta)$
through the change of the variable (polar coordinates) $u=\omega \cos \theta, v=\omega \sin \theta, d u d v=|\omega| d \omega d \theta$, we obtain:
$J_{z}(x, y)=\iint F(\omega \cos \theta, \omega \sin \theta) e^{2 i \pi \omega \cdot(x \cos \theta+y \sin \theta)}|\omega| d \omega d \theta$
$J_{z}(x, y)=\int d \theta \int d \omega|\omega| G_{\theta}(\omega, \theta) e^{2 i \pi \omega(x \cos \theta+y \sin \theta)}$
$\mathrm{J}_{\mathrm{z}}(\mathrm{x}, \mathrm{y})=\int \mathrm{d} \theta \mathbf{T F}^{-1}\left[|\omega| \mathrm{G}_{\theta}(\omega, \theta)\right](\mathrm{x} \cos \theta+\mathrm{y} \sin \theta)$
If we assume a discrete measurement at equidistant angles, we get:
$\mathrm{J}_{\mathrm{z}}(\mathrm{x}, \mathrm{y}) \sim \Delta \theta \sum_{\theta_{\mathrm{k}}} \mathbf{T F}^{-\mathbf{1}}\left[|\omega| \mathrm{G}_{\theta_{\mathrm{k}}}(\omega)\right]\left(\mathrm{x} \cos \theta_{\mathrm{k}}+\mathrm{y} \sin \theta_{\mathrm{k}}\right)$

This defines the inverse Radon transform by filtered backprojection ${ }^{15}$. Then from measuring current intensity on the wire for each $p$ position and each $\theta$ orientation around the beam we can go back to beam density profile $J_{z}(x, y)$.

## III. EXPERIMENTAL SET-UP

## A.Mechanical assembly



Figure 3: Installation of the scanner device inside the collision chamber, on the left, the Faraday cup used to measure the beam intensity
The mechanical assembly is shown in figure 3. The assembly is made of brass and aluminum (AU4G) in order to minimize the magnetic stray fields which can be of importance for low energy electron beam density profile measurement, ferrite shields can also be used to shield motors. The wire used is made of copper, has a diameter of 0.4 mm and is sufficiently stiff. This is important because, unlike other scanning devices ${ }^{12,13}$, the wire is only attached at one end.
The working surface of the developed scanner is a 25 mm diameter disk, the diameter of the scanned beam should therefore not exceed 25 mm . A three-part brass gear (purchased from HPC (https://shop.hpceurope.com/fr), each with a pitch diameter of $9 \mathrm{~mm}, 35 \mathrm{~mm}, 50 \mathrm{~mm}$ ) rotates the linear scanning part. Only 0.5 module (ratio of the pich circle diameter to the number of teeth, gears will only mesh with each other if they have the same module) gears are available. The largest gear has been modified to fit our assembly in order to create an empty disc with a diameter of 25 mm to allow the beam to pass through the scanner. The gearwheels are attached to the Dural support by brass parts. These have been carefully adjusted to ensure good mechanical centering, but also to minimize friction. A 0.02 mm mechanical tolerance was a good compromise. A number of motors were tested (to find the one with the right characteristics in size and torque) and a different support was made for each of them.

## B. Electronic control

In order to measure $g_{\theta_{\mathbf{k}}}$ (p) (see eq. 5), we have to carry out a controlled $180^{\circ}$ rotation (with a good angular precision) and, at each angle, a linear scan (see figure 2) with a measurement of the current on the wire. To do this, we use two low cost commercial 5V stepper motors, namely:
i)_a 28BYJ-48 for rotation with a high resolution of 2048 steps per revolution which coupled with the gear reduction (5.555) gives a resolution of 0.0315 degree/step on the rotating part.
ii)_a DFRobot FIT0708 assembly for the wire translation is consisting of a 20 steps per revolution stepper motor coupled to a threaded rod and a linear displacement screw. This results in a resolution of $20 \mu \mathrm{~m} /$ step in the translational part.

The rotation and scanning sequences are programmed on an Arduino Uno microcontroller and the Adafruit Motor/Stepper/Servo Shield for Arduino v2 Kit - v2.3 allows us to simply drive the rotation of the two motors by an adapted library (figure 4).


Figure 4: Synoptic scheme of the motor driving
With the homemade stroke ends, the initial rotation angle positioning as well as the initial scan position are realized and verified during the scanning process.

The total beam intensities that we use in our research applications range from $\sim 100 \mathrm{nA}$ to $\sim \mu \mathrm{A}$ and the current measured on the wire is about $\sim 1-10 \mathrm{nA}$. A conversion current-voltage is first processed through a resistor $\mathrm{R}=5 \mathrm{M} \Omega$ and a capacitor $\mathrm{CF}=1 \mathrm{nF}$ is used for noise filtering. The corresponding voltage is then amplified by an adjustable gain of 2-20-200 and the final tension corresponds to $\mathrm{V}(\mathrm{Volt})=0.01-0.1-1 * \mathrm{I}(\mathrm{nA})$. Of course, the values may be subject to change for specific purposes.
This voltage is inverted or not depending on the sign of the current measured on the wire, because the analog inputs of the Arduino must be positive and less than or equal to 5V. The TLE2074ACN quadruple operational amplifier was selected for its FET (field effect transistor) inputs, which are designed for low input currents and an offset compensation is applied because the TLE2074ACN circuit does not have one. The electronic scheme is given in figure 5.


Figure 5: Electronic scheme of the current amplifier
The whole electronic assembly is illustrated in figure 6.
A special vacuum flange has been designed for the transmission of motor commands, limit switches and the wire signal between the external electronics module and the in-vacuum scanner.


Figure 6: Electronic circuits. left: Arduino and Motor shield, right: home-made current amplifier shield

## C. Computer monitoring

The selection of the angle step is done by means of a home-made code and send to the Arduino micro controller which begin the scan procedure in both angle and linear: the total area ( 25 mm ) must be done in $2^{n}$ steps adapted to the Fast Fourier Transform and 256 steps ( $0.1 \mathrm{~mm} / \mathrm{step}$ ) are sufficient for beams with a diameter of a few mm . The data (position, angle and wire current) are sent from the Arduino board to the computer directly via the serial link (wireless transmission can also be used), are stored in a file and are displayed (sinogram) in real time. Finally, a C++ procedure using the direct and inverse Fast Fourier transforms is called to compute the inverse Radon transform implementing the equation 9 . Beam profile is plotted on screen and also stored into file.
A 256 point linear scan takes 3 seconds, the entire acquisition for a $10^{\circ}$ rotation step from $0^{\circ}$ to $170^{\circ}$ takes 54 seconds, the inverse Radon transform calculation time is 2 seconds, so the entire procedure takes just a minute. Each scan on p is normalized so that the integral is equal to the beam current that was previously measured via a Faraday cup, the normalization avoids any fluctuation in the intensity of the beam, which can be a source of uncertainty in the inverse Radon transform.

## D. Region of application and limits

Our mini scanner analyzes beams <25mm in size. There is no limit for small width beam, nevertheless the wire diameter has to be smaller than the beam width in order to neglect it (the measured profile is a convolution between the wire diameter and the real beam profile). For wires with a diameter of a few tenths of a millimeter, the minimum beam size must be a few millimeters. Vibration of the wire due to translational motion must be minimized by reducing the corresponding translational speed.
Due to stepper motors, our device is not designed for ultra-high vacuum.

## IV.TESTS: EXPERIMENTAL RESULTS

The device was placed in our collision chamber in front of our electron gun (ELG-2 from Kimball Physics) at a distance of about 20 cm . The electron gun was chosen for the tests because it is easier to change the focus and deflection.
Of course, the motors are not designed for vacuum. However, after two days of pumping, a residual pressure of $2.10^{-7}$ Torr can be achieved (the volume of the vacuum chamber is $\sim 1.510^{5} \mathrm{~cm} 3$ and pumping is carried out using a $1000 \mathrm{l} / \mathrm{s}$ turbo pump). The first few runs of the scanner will cause quite a bit of degassing. This is due to the heating of the coils and the rotation of the motors.
For the tests, a 200 eV beam was produced and a $10^{\circ}$ step for the rotation was chosen.

## A. Focalization of the beam

We have made images of the beam for two values of focus of the electron gun. The respective sinograms are given in figure 7. They are relatively flat indicating that the electron beam is rather centered. The width of the curve is smaller in the top case
(focalization voltage $=300 \mathrm{~V}$ ) than in the bottom case (focalization voltage $=350 \mathrm{~V}$ ) revealing a smaller beam width. The 2D profile of the beam is obtained by applying the inverse Radon transform showing the full 2D profile of the beam.
The images confirm the previous deduction: the beam is quite centered ( $\mathrm{xc}=-0.35 \pm 0.04 \mathrm{~mm}$ and $\mathrm{yc}=-1.3 \pm 0.04 \mathrm{~mm}$ ) and the FWHM increases from $1.5 \pm .2 \mathrm{~mm}$ to $2.5 \pm .2 \mathrm{~mm}$ when the focalization is varied.


Figure 7: Effect of focalization. Left: sinogram, right: density. Top: good focalization (300V), bottom: bad focalization (350V)

A control of the size of the beam is easily realized.

## B. Deflection of the beam

We also checked the control of the position of the through the deflection. The focus of the electron gun is set at 300 V . The sinograms, reconstruction and deflection electrodes and their polarization (verified in situ) are shown in figure 8.






Figure 8: Effect of the deflection. Top: horizontal. Bottom: vertical

The beam is moved in the correct direction based on the polarization of the electrodes. The deflections are not strictly horizontal or vertical and both have undergone a $12^{\circ}$ shift which is not due to the scanner imaging but to the rotation of the deflection electrodes in our electron gun positioning as shown in figure 9.


Figure 9: Rotation of the electron gun
The beam deflection (and corresponding displacement) is fully described by the scanning device, and the electron gun's positioning error has been revealed.

## VI. CONCLUSION AND OUTLOOK

In this paper, we show the realization of a small charged diagnostic beam that allows the complete determination of the 2D current density at a given transverse position. For this purpose, we used the CT technique in which the beam is scanned at different angles. The technical implementation includes stepper motors for linear motion as well as high resolution rotation, mounted on precisely adjusted gears. An Arduino microcontroller is used to drive the stepper motors and acquire the current on the wire at each angle and position. The reconstruction of the density from all the measured profiles is done by inverse Radon transformation. The whole easy-to-use setup and the associated code/interface have been tested in the case of focusing and beam deflection of an electron beam and the expected behaviors have been found. One improvement to the setup is to reduce the wire diameter to $\sim 0.2 \mathrm{~mm}$ to increase resolution. Another mode of operation where the wire (grounded) does not measure the current but acts as a mask in front of a Faraday cage can be considered, the difficulty lies in measuring a small variation of current. A complete determination of the beam geometry and 3D current density can be obtained by moving the setup along the beam direction and creating profiles for different z-directions and interpolating between them.

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